

Feng, Xiaobing and Quagliotti, Danilo and Maculotti, Giacomo and Syam, Wahyudin P. and Tosello, Guido and Hansen, Hans N. and Galetto, Maurizio and Leach, Richard (2017) Measurement noise of a point autofocus surface topography instrument. In: 16th Conference on Metrology and properties of Engineering Surfaces, 27-29 June 2017, Göteborg, Sweden.

Access from the University of Nottingham repository:

<http://eprints.nottingham.ac.uk/44022/1/MP%202.pdf>

Copyright and reuse:

The Nottingham ePrints service makes this work by researchers of the University of Nottingham available open access under the following conditions.

This article is made available under the University of Nottingham End User licence and may be reused according to the conditions of the licence. For more details see:
http://eprints.nottingham.ac.uk/end_user_agreement.pdf

A note on versions:

The version presented here may differ from the published version or from the version of record. If you wish to cite this item you are advised to consult the publisher's version. Please see the repository url above for details on accessing the published version and note that access may require a subscription.

For more information, please contact eprints@nottingham.ac.uk

Measurement noise of a point autofocus surface topography instrument

Xiaobing Feng¹, Danilo Quagliotti², Giacomo Maculotti³, Wahyudin P Syam¹, Guido Tosello², Hans N Hansen², Maurizio Galetto⁴, Richard Leach¹

¹Manufacturing Metrology Team, Faculty of Engineering, University of Nottingham, UK

²Department of Mechanical Engineering, Technical University of Denmark, Denmark

³Dipartimento di Ingegneria Meccanica e Aerospaziale, Politecnico di Torino, Italy

⁴Dipartimento di Ingegneria Gestionale e della Produzione, Politecnico di Torino, Italy

E-mail: xiaobing.feng@nottingham.ac.uk

Keywords: areal, measurement, noise, surface, texture, point autofocus, optical, microscope

Abstract Optical instruments for areal topography measurement can be especially sensitive to noise when scanning is required. Such noise has different sources, including those internally generated and external sources from the environment [1]. For some instruments, it is not always possible to evaluate each single contributor. Nevertheless, it is possible to evaluate the noise added to the output during the normal use of the instrument. Such noise is defined in ISO 25178 part 605 [1] as “measurement noise”. In this work, the measurement noise is assessed for a commercial point autofocus instrument (Mitaka MLP-3SP), installed in the manufacturing metrology laboratory at The University of Nottingham. The investigation is carried out by areal acquisitions of $100\ \mu\text{m} \times 100\ \mu\text{m}$ with a $100\times$ magnification objective and a sampling distance of $0.1\ \mu\text{m}$ along the x -axis and $1\ \mu\text{m}$ along the y -axis. The measurement noise is evaluated by applying established subtraction and averaging methods described elsewhere [2, 3]. The results reveal a maximum calculated value of $20\ \text{nm}$ (subtraction method) and a minimum of $8\ \text{nm}$ (subtraction method). An oscillation is observed in the acquired surface topographies, which is due to a thermal drift induced by the air conditioning system. The disturbance can be reduced using the temperature correction tool in the software of the instrument. Experiments performed when the air conditioning system is inactive, showed drift of the instrument due to the temperature which is estimated, in the worst case, as $0.9\ \mu\text{m}/^\circ\text{C}$ (calculated as $S_z/\Delta T$), over one hour measuring time. The investigation was then repeated applying the temperature correction tool and the evaluation of the measurement noise results in a value of $2\ \text{nm}$ (both methods). The overall temperature variation, measured in the housing chamber of the instrument, is smaller than $0.1\ ^\circ\text{C}$ during each repeated measurement. In conclusion, the point autofocus instrument shows a clear dependence on the environmental noise. The measurement noise uncertainty contributor in the worst case is estimated to be $u_{\text{noise}} = 20\ \text{nm}$ when the temperature correction tool

is not applied [2]. The use of the built-in temperature correction tool allows the measurement noise uncertainty contributor to be reduced to $u_{noise} = 2$ nm.

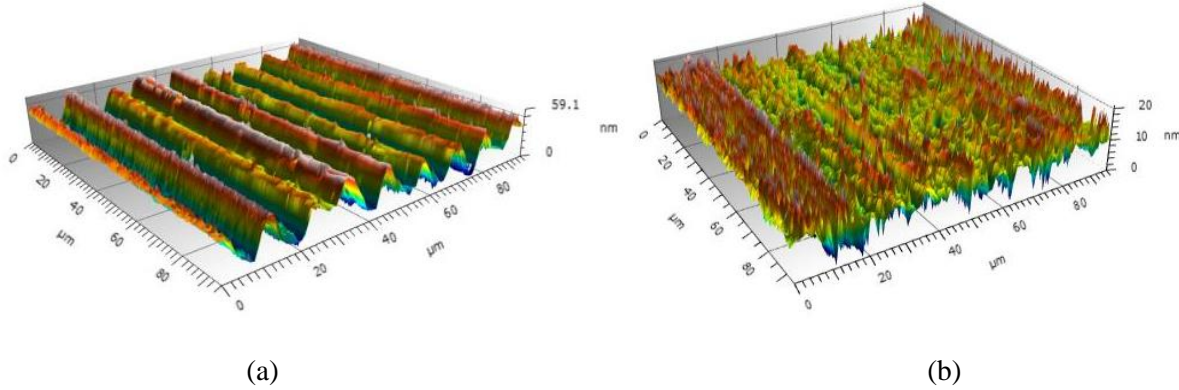


Figure 1. (a): Areal acquisition of an optical flat; the measurement is affected by periodic disturbances. (b): areal acquisition of an optical flat applying the temperature correction tool.

Table 1. Measurement noise results for averaging method ($Sq_{noise,ave}$) and subtraction method ($Sq_{noise,sub}$) without using the temperature correction tool.

Averaged measurements	2	3	4	5	6	7	8	9	10	11	12	13
$Sq_{noise,ave}/nm$	15.6	12.5	15.0	14.7	14.0	13.3	13.1	13.4	13.4	13.7	13.7	14.1
Subtractions	1	2	3	4	5	6	7	8	9	10	11	12
$Sq_{noise,sub}/nm$	15.9	7.6	18.2	10.7	8.4	8.2	8.8	15.9	17.2	19.0	18.5	20.3

Table 2. Measurement noise results for averaging method ($Sq_{noise,ave}$) and subtraction method ($Sq_{noise,sub}$) applying the temperature correction tool.

Averaged measurements	2	3	4	5	6	7	8	9	10	11	12	13	14	15
$Sq_{noise,ave}/nm$	1.7	2.1	1.9	2.0	2.1	2.1	2.1	2.1	2.1	2.1	2.1	2.1	2.1	2.1
Subtractions	1	2	3	4	5	6	7	8	9	10	11	12	13	14
$Sq_{noise,sub}/nm$	2.1	1.9	2.0	1.8	2.3	2.3	2.2	2.1	1.8	2.1	2.1	1.9	2.0	2.2

Main References

- [1] ISO 25178-605: 2014 (2014) Geometrical product specification (GPS) — Surface texture: Areal – Part 605: Nominal characteristics of non-contact (point autofocus probe) instruments (International Organization of Standardization)
- [2] Giusca C L, Leach R K, Helary F, Gutauskas T and Nimishakavi L (2012) Calibration of the scales of areal surface topography-measuring instruments: part 1. Measurement noise and residual flatness *Meas. Sci. Technol.* **23** 35008
- [3] Giusca C L and Leach R K (2012) Calibration of the metrological characteristics of Imaging Confocal Microscopes (ICMs) NPL Good Practice Guide No. 128 (Teddington, UK: National Physical Laboratory)